

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No.:10/695,336

Applicant(s): Geiss et al.

Filed.: October 28, 2003

Art Unit: 2813

Dkt. No.: BUR920010184US2

Examiner: DOTY, HEATHER ANNE

Title: **METHOD OF CONTROLLING GRAIN SIZE IN A POLYSILICON LAYER AND  
IN SEMICONDUCTOR DEVICES HAVING POLYSILICON STRUCTURES**

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Honorable Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**REQUEST FOR RECONSIDERATION**

This Request for Reconsideration is being filed in response to the Final Office Action mailed on January 29, 2007. Applicants request this Amendment be entered in the above-identified application and reconsideration of the application in view of the Amendments and Remarks that follow.